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## PATENT ABSTRACTS OF JAPAN

(11) Publication number : 05-339723  
 (43) Date of publication of application : 21.12.1993

(51) Int.CI.

C23C 14/34  
C23C 14/56

(21) Application number : 04-150171  
 (22) Date of filing : 10.06.1992

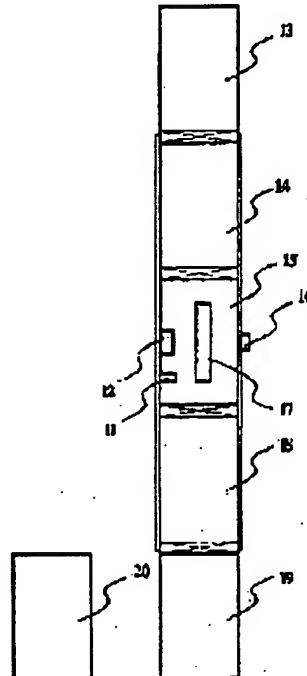
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## (54) INLINE SPUTTERING DEVICE

## (57) Abstract:

PURPOSE: To provide the inline sputtering device having excellent productivity by providing a means for measuring the rotating speeds of pallets carrying substrates to be formed with films and a means for accumulating the measured values thereof for each of carriers.

CONSTITUTION: This inline sputtering device is provided with a chamber group which has at least a loading chamber 14 for loading the substrates to be formed with the films, a sputtering chamber 15 for forming the films by sputtering on the substrates to be formed with the films and an unloading chamber 18 for unloading these substrates, the carriers 17 which have the pallets carrying the substrates to be formed with the films and move between the respective chambers of the chamber group and a rotational driving device 16 for the pallets which is mounted on the carriers 17 and moves the pallets of the carriers 17 while rotating the pallet. The respective carriers are identified by a carrier identifying mechanism 12 of the sputtering chamber 15 and the rotating speeds of the pallets carrying the substrates to be formed with the films are measured by a mechanism 11 for measuring the rotating speeds of the pallets. The measured values are accumulated for each of the carriers by a control panel 20.



## LEGAL STATUS

|   |            |
|---|------------|
| [Date of request for examination]   | 28.06.1996 |
| [Date of sending the examiner's decision of rejection]  | 08.09.1998 |
| [Kind of final disposal of application other than the examiner's decision of rejection or application converted registration] |            |
| [Date of final disposal for application]  |            |
| [Patent number]   | 3001333    |
| [Date of registration]  | 12.11.1999 |
| [Number of appeal against examiner's decision of rejection]   | 10-15954   |
| [Date of requesting appeal against examiner's decision of rejection]  | 08.10.1998 |

[Date of extinction of right]

12.11.2002

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